

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
: Takahiro MATSUO, et al. :
: Serial No.: :
(Divisional of Serial No. 09/326,541) : Group Art Unit:
: Filed: April 17, 2000 : Examiner:-
: For: PATTERN FORMING MATERIAL AND PATTERN FORMING METHOD

Honorable Commissioner of
Patents and Trademarks
Washington, D. C. 20231

CORRESPONDENCE ADDRESS CHANGE

Sir:

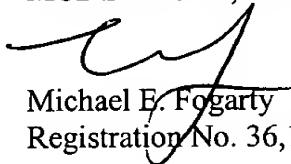
Please change the records to indicate the current firm name and telephone number for the
above-identified application and forward all future correspondence as follows:

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Respectfully submitted,

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